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ATTORNEYS AT LAW

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ONE METROPOLITAN SQUARE
16TH FLOOR
ST. LOUIS, MISSOURI 63102
314-231-5400



December 4, 2000

FACSIMILE 314-231-4342
<http://www.senniger.com>

PATENTS, TRADEMARKS, COPYRIGHTS
AND RELATED MATTERS

OF COUNSEL
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STUART N. SENNIGER
(1921-1997)

Application of Gregory Michael Wilson et al.
Serial No. 09/608,302
Filed June 30, 2000
For METHOD AND APPARATUS FOR FORMING A SILICON
WAFER WITH A DENUDED ZONE
Attorney Docket No. MEMC 98-4650(2293)

Group Art Unit 1765

Office of Initial Patent Examination
Customer Service Center
Assistant Commissioner for Patents
Washington, D.C. 20231

Sir:

We have received the corrected filing receipt in the above-referenced U.S. patent application.

The filing receipt still shows the inventors as Gregory **Micheal** Wilson, Chesterfield, MO; **Micheal** John Ries, St. Charles, MO. whereas the correct information Gregory **Michael** Wilson, Chesterfield, MO; **Michael** John Ries, St. Charles, MO.

Please send us a corrected filing receipt.

Respectfully submitted,

Edward J. Hejlek, Reg. No. 31,525

EJH/dep

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Bib Data Sheet

SERIAL NUMBER 09/608,302	FILING DATE 06/30/2000 RULE -	CLASS 438	GROUP ART UNIT 1765	ATTORNEY DOCKET NO. MEMC-98-4650 (2293)	
APPLICANTS Gregory Michael Wilson, Chesterfield, MO ; Michael John Ries, St Charles, MO ; ** CONTINUING DATA ***** ** FOREIGN APPLICATIONS *****					
IF REQUIRED, FOREIGN FILING LICENSE GRANTED ** 08/30/2000					
Foreign Priority claimed <input type="checkbox"/> yes <input checked="" type="checkbox"/> no 35 USC 119 (a-d) conditions met <input type="checkbox"/> yes <input checked="" type="checkbox"/> no <input type="checkbox"/> Met after Allowance Verified and Acknowledged <input checked="" type="checkbox"/> <u> </u> Examiner's Signature <u> </u> Initials <u> </u>		STATE OR COUNTRY MO	SHEETS DRAWING 4	TOTAL CLAIMS 20	INDEPENDENT CLAIMS 2
ADDRESS 000321					
TITLE Method and apparatus for forming a silicon wafer with a denuded zone					
FILING FEE RECEIVED 840	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:		<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit		



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APPLICATION NUMBER	FILING DATE	GRP ART UNIT	FIL FEE REC'D	ATTY. DOCKET NO	DRAWINGS	TOT CLAIMS	IND CLAIMS
09/608,302	06/30/2000	1765	840	MEMC-98-4650(2293)	4	20	2

000321
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OC000000005569646
 OC0000000005569646

Date Mailed: 11/21/2000

Receipt is acknowledged of this nonprovisional Patent Application. It will be considered in its order and you will be notified as to the results of the examination. Be sure to provide the U.S. APPLICATION NUMBER, FILING DATE, NAME OF APPLICANT, and TITLE OF INVENTION when inquiring about this application. Fees transmitted by check or draft are subject to collection. Please verify the accuracy of the data presented on this receipt. If an error is noted on this Filing Receipt, please write to the Office of Initial Patent Examination's Customer Service Center. Please provide a copy of this Filing Receipt with the changes noted thereon. If you received a "Notice to File Missing Parts" for this application, please submit any corrections to this Filing Receipt with your reply to the Notice. When the PTO processes the reply to the Notice, the PTO will generate another Filing Receipt incorporating the requested corrections (if appropriate).

Applicant(s)

Gregory Michael Wilson, Chesterfield, MO ;
 Michael John Ries, St Charles, MO ;

michael
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Continuing Data as Claimed by Applicant

Foreign Applications

If Required, Foreign Filing License Granted 08/30/2000

Title

Method and apparatus for forming a silicon wafer with a denuded zone

Preliminary Class

438

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Data entry by : DADE, JOAN

Team : OIPE

Date: 11/21/2000

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